



Docket No.:0756-7244

*jpu*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Koichiro TANAKA, et al. )  
Serial No. 10/749,505 ) Group Art Unit: 2828  
Filed: January 2, 2004 ) Examiner: A. Rodriguez  
For: LASER IRRADIATION METHOD, METHOD )  
FOR MANUFACTURING SEMICONDUCTOR )  
DEVICE, AND LASER IRRADIATION SYSTEM )

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
The United States Postal Service with sufficient postage as First  
Class Mail in an envelope addressed to: Commissioner for Patents,  
P. O. Box 1450, Alexandria VA 22313-1450, on November 4, 2005

*Henry A. Rusei*

**SECOND REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

*Eric J. Robinson*

Eric J. Robinson  
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.  
PMB 955  
21010 Southbank Street  
Potomac Falls, Virginia 20165  
(571) 434-6789  
(571) 434-9499 (Fax)